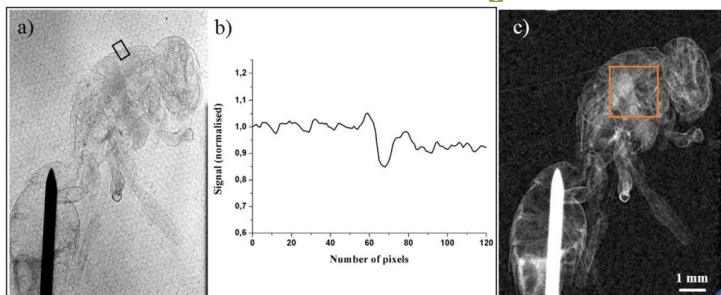
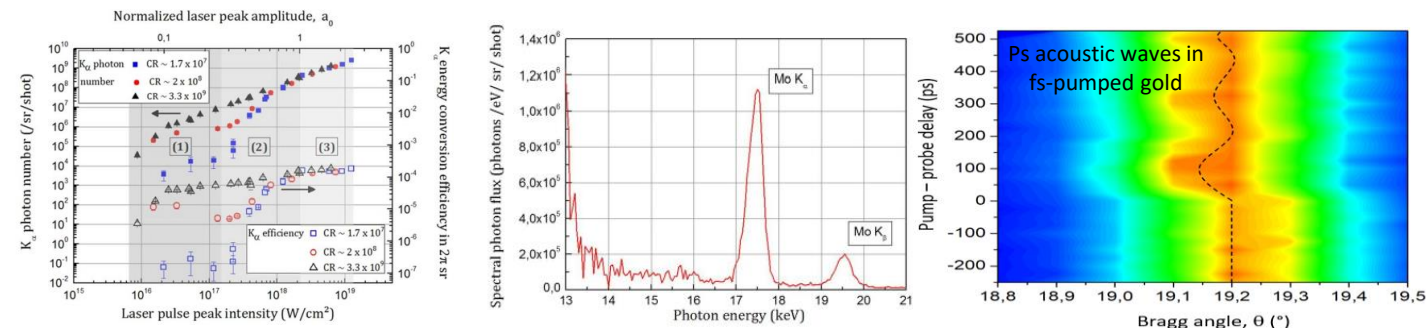


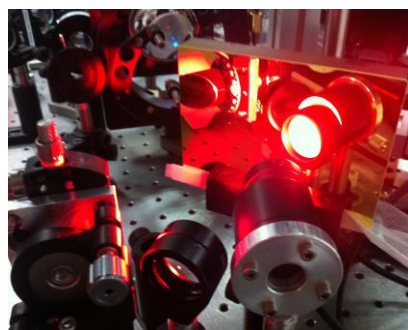
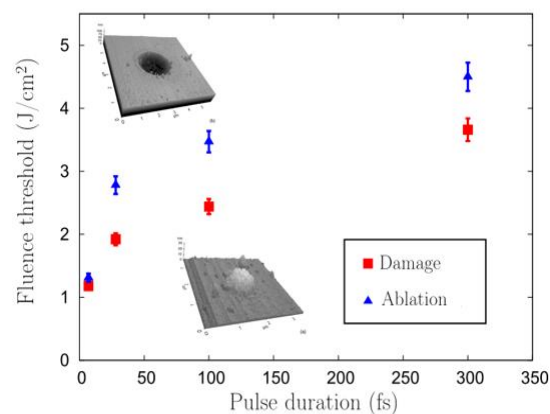
Test-bench 3 - X-ray biomedical imaging and non-destructive testing



Test-bench 4 - X-ray source generation and time-resolved X-ray diffraction and material science



Test-bench 1 – Ultrashort Laser damage metrology



Test-bench 2 - Laser-matter interaction, ablation and direct-laser-writing (metaphotonic structures in dielectrics-left, local writing in semiconductors-center and metals fluence processing-right)

